

_	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/629,430	CHOI ET AL.	
	Examiner	Art Unit	
	Scott Geyer	2812	

SEARCHED					
Class	Subclass	Date	Examiner		
search	updated	9/30/2006	SBG		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	terference arch	9/30/2006	SBG		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EADT search notes attached	9/30/2006	SBG		